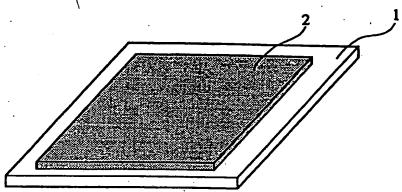
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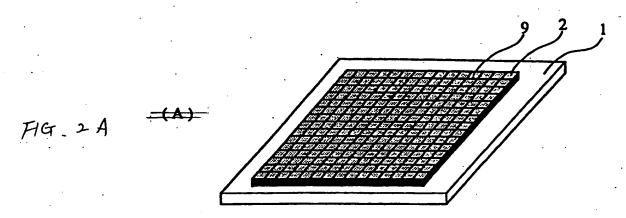
FIG. 1 A



<del>(B)</del>

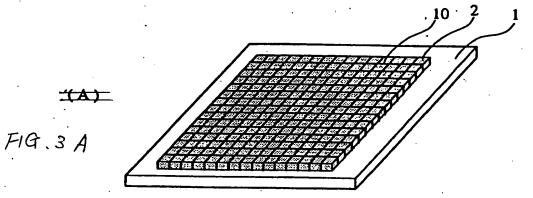
FIG. 1B

【图2】

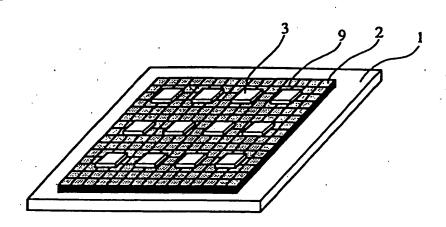




-{図3]



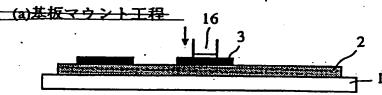
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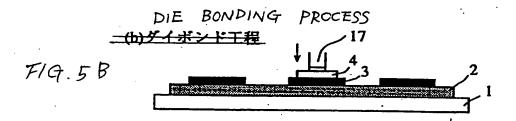


【図5】

SUBSTRATE MOUNTING PROCESS

FIG.5A





WIRE BONDING PROCESS

FIG.5C

<del>(c)ワイヤポンド工程</del>

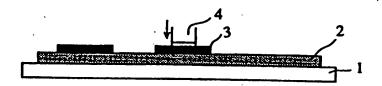
1 (1) a

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【図6】

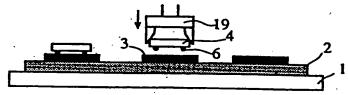
SUBSTRATE MOUNTING PROCESS

HG.6A



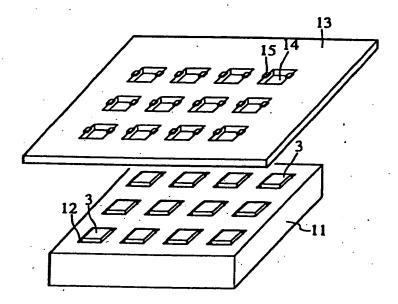
BUMP BONDING PROCESS (b)バンプ接合工程

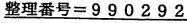
F19.6B

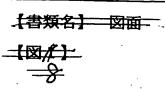


【図7】

F19.7

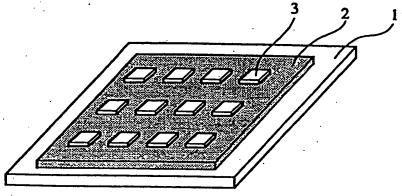


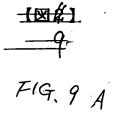


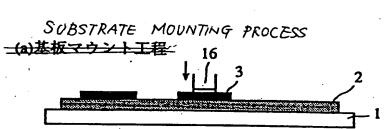


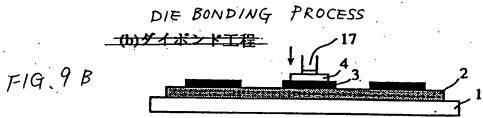
F19.8

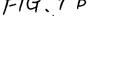
\* ( ) d











PROCESS WIRE BONDING (c)ワイヤボンド工程

F19.9C

